

Interference Search

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1		700/118,119,121.ccls.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2006/11/30 16:30
L2		l1 and ((substrate or wafer) and retention).clm.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2006/11/30 16:31
L3		l1 and ((substrate or wafer) and unconsolidated).clm.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2006/11/30 16:31
L4		l1 and ((substrate or wafer) and bottom and fabricat\$3).clm.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2006/11/30 16:31
L5		l1 and ((substrate or wafer) and circulat\$3).clm.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2006/11/30 16:32
L6		l1 and ((substrate or wafer) and protrud\$3).clm.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2006/11/30 16:33
L7		l1 and ((substrate or wafer) and excess).clm.	US-PGPUB; USPAT; EPO; JPO	OR	OFF	2006/11/30 16:33